

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION**

APPLICANT: Yasuhito Inagaki, et al. ATTY. DOCKET NO. 09792909-5081

SERIAL NO.

DATE FILED:

INVENTION: "SUBSTRATE CLEANING METHOD AND SUBSTRATE CLEANING APPARATUS"

Assistant Commissioner of Patents  
Washington, D.C. 20231

SIR:

Between the title and the heading "Background of the Invention" on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Applications Nos. P2000-214974 filed July 14, 2000, and P2000-240134 filed August 8, 2000, which applications are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

  
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